

Title (en)

METHOD FOR PRODUCTION OF A THIN-LAYER STRUCTURE

Title (de)

VERFAHREN ZUM HERSTELLEN EINER DÜNNSCHICHT-STRUKTUR

Title (fr)

PROCEDE DE PRODUCTION D'UNE STRUCTURE A COUCHE MINCE

Publication

EP 1854104 A1 20071114 (DE)

Application

EP 06705966 A 20060213

Priority

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Abstract (en)

[origin: WO2006092114A1] A sacrificial layer is applied in a macroporous support structure substrate. The back face of the support structure substrate is then partly removed such as to expose a region of the sacrificial layer on the back face of the support structure substrate. A thin layer is applied to the back face surface of the support structure substrate and the exposed regions of the sacrificial layer and in the pores a material removal is carried out as far as the thin layer such that the pore bases are formed from the thin layer.

IPC 8 full level

B81C 1/00 (2006.01); **G21K 1/02** (2006.01)

CPC (source: EP KR US)

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See references of WO 2006092114A1

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DOCDB simple family (publication)

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